## <u>ABSTRACT</u>

- 1 An exhaust gas from a chemical vapour deposition process may contain ammonia
- and metalorganic vapour, such as TMG. In a treatment process to remove these
- 3 substances from the exhaust gas, the exhaust gas is exposed to an ammonia
- 4 decomposition catalyst to convert the ammonia into nitrogen and hydrogen. In order
- to avoid deposition of carbon on the surface of the catalyst, the exhaust gas is first
- 6 exposed to a heated bed of dry, granular materials to cause the metalorganic vapour
- to decompose before the exhaust gas is exposed to the aluminium decomposition
- 8 catalyst.